Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	7353	(first adj conductive adj layer) same (second adj conductive adj layer) same (dielectric insulat\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 12:05
S2	10	S1 same ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:19
S3	35	S1 and ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:24
S4	77	conductive with ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:52
S5	23	S1 and S4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:52
S6	0	S5 not S3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:25
S7	34	barrier with ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:53
\$8 	8	S1 and S7	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/01/21 00:53

\$9 	10	S1 same ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:54
S10	1	"5461425".PN.	USPAT; USOCR	OR	OFF	2006/01/21 00:54
S11	31	((platinum-rhodium adj alloy) or ("Pt-Rh")) adj (film layer)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:44
\$12	9	@ad <= "19980826" and S11	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:48
S13	22	((platinum-rhodium or "Pt-Rh") adj alloy) with ("CVD" or (chemical adj vapor adj deposition))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:52
Ş14	2	@ad <= "19980826" and S13	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:53
\$15	4070	alloy with ("CVD" or (chemical adj vapor adj deposition))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:53
\$16 :	1760	@ad <= "19980826" and S15	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:53
S17	132	S16 and capacitor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 17:20

S18	3	S17 and ((platinum-rhodium adj alloy) or ("Pt-Rh"))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 15:54
S19	2	("6180974").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 18:10
\$20	2	("5608287").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 20:44
S21	2	"20020036296"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 20:46
S22	2	("5739552").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:58
\$23 ;	216	(transparent adj (layer film)) with ((semiconductor silicon) near2 (material compound))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:25
\$24	2	S21 and (LED (light adj emitting adj diode))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:26
S25	31	S23 and (LED (light adj emitting adj diode))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:27

\$26	14	@ad <= "20020625" and S25	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:50
S27	11947	"GaP" with transparent	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:59
\$28	4102	("GaP" with transparent).ab.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/07/23 21:59

7/23/06 11:14:13 PM C:\Documents and Settings\TTran13\My Documents\EAST\Workspaces\10755097.wsp